

Notice of References Cited	Application/Control No. 10/634,229	Applicant(s)/Patent Under Reexamination BANSAL, JAI P.	
	Examiner Sun J Lin	Art Unit 2825	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,723,883	03-1998	Gheewalla	257/204
	B	US-6,091,090	07-2000	Gheewala	257/211
	C	US-6,466,054 B2	10-2002	Kameyama et al.	326/68
	D	US-6,538,470 B1	03-2003	Langhammer et al.	326/41
	E	US-2003/0101307 A1	05-2003	Gemelli et al.	710/305
	F	US-6,710,621 B2	03-2004	Devlin et al.	326/38
	G	US-6,747,478 B2	06-2004	Madurawe	326/39
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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